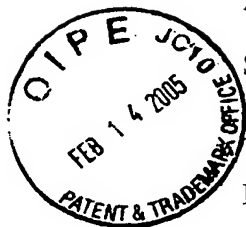


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicant: Xiangjun Wang

Serial No.: 10/519,899

Filed: July 7, 2003

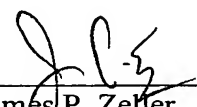
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INFORMATION DISCLOSURE STATEMENT

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Submitted herewith for consideration by the examiner are copies of the documents identified on the attached Form PTO-1449.

Entry and consideration of the submitted documents are solicited.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

February 11, 2005

By: 
_____ James P. Zeller
Reg. No. 28,491
Attorneys for Applicants

6300 Sears Tower
233 South Wacker Drive
Chicago, Illinois 60606-6357
(312) 474-6300

Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 29610/CDT334	Serial No. 10/519,899
INFORMATION DISCLOSURE STATEMENT		Applicant Wang	
		Filing Date July 7, 2003	Group

U.S. PATENT DOCUMENTS							
*Examiner Initials		Document Number	Issue Date	Name	Class	Subclass	Filing Date if Appropriate

FOREIGN PATENT DOCUMENTS								
*Examiner Initials		Document Number	Publication Date	Country	Class	Subclass	Translation	
							Yes	No
		880 303 B1	11/25/98	EPO				
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	Search Report in GB 0215858.2 dated February 25, 2003

Examiner	Date Considered
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